SHEET I OF 1										
INFORMATION DISCLOSURE CITATION IN AN					ATTY. DOCKET NO. 63979-032		SERIAL NO. 10/643,944			
VIDE.	X Al	'PL	LICATION							
APR 20 MIN S					APPLICANT . Yoshiaki HASEGAWA, et al.					
					FILING DATE GROUP					
(PTO-1449)					August 20, 2003					
(PTO-1449) FILING DATE GROUP 2%28										
EXAMINER'S	EXAMINER'S Document Number Publication				Name of Patentee or Appli	stentee or Applicant of Cited		Pages, Columns, Lines, Where		
INITIALS	CITE NO.	Number-Kind Codez (7 known)		MM-DD-YYYY	Document		Relevant Passages or Relevant Figures Appear			
M	_	US	5,345,483	09/06/1994	Mannoh et al.	Mannoh et al.				
		US								
		US			·					
		<u>င</u> ှု နှ					ļ			
		05		FOREIGN PA	TENT DOCUMENTS		<u> </u>			
FOREIGN PATENT DOCUMENTS EXAMINER'S Foreign Patent Document Publication Date Name of Patentee or Pages, Columns, Lines Translation										
INITIALS	CITE NO.	Country Codes -Number 4 -Kind Codes (if known)		MM-DD-YYYY	Applicant of Cited Document	Where Relevant Figures Appear				
		JP 10-200214 A		07/31/1998	NEC CORP			Yes	No	
W	\	JP 10-200214 A JP 6-283825 A		10/07/1994	TOYODA GOSEI CO., LTD.	<u> </u>			х.	
200	 		JP 4-275479 A	10/01/1892	NEC CORP.			\vdash	x	
200	. \		JP 2000-21789	01/21/2000	TOSHIBA CORP.	1	$\overline{}$		×	
-\$VP			JP 5-291686	11/05/1893	•				X	
Coll	1	JP 11-251687 -		09/17/1999	•				X	
OTHER ART (Including Author, Title, Date, Perlinent Pages, Etc.)										
EXAMINER'S INITIALS										
en	ŀ	GOTO, S., et al. " InGaN: Improvement of quantum efficiency by InGaN Interlayer for blue-violet laser diodes." Sony Shiroishi Semiconductor Inc. 28p-E-12, Page 369								
CW		NAKAMURA, Shuji. "InGaN Multiquantum-Well-Structure Laser Diodes with GaN-AlGaN Modulation –Doped Strained-Layer Superlattices." IEEE Journal of Selected Topics in Quantum Electronics, Vol. 4, No.3, May/June 1998, pp. 483-489								
LNS		KNEISSL, Michael., et al. "Performance and degradation of continuous-wave InGaN multiple-quantum-well laser diodes on epitaxially laterally overgrown GaN substrates." Applied Physics Letters, Volume 77, Number 13, September 25, 2000, pp. 1931-1933								
<i>2</i> 1/1 0		NAKAMURA, Shuji., et al. " UV/Blue/Green InGaN-Based LEDs and Laser Diodes Grown on Epitaxially Laterally Overgrown GaN." IEICE Trans. Electron., Vol E83-C, No. 4, April 2000, pp. 529-535							,	
KN		TOJYO, Tsuyoshi., et al. "GaN-Based High Power Blue-Violet Laser Diodes." The Japan Society for Applied Physics, Volume 40, Part 1. No. 5A, May 2001, pp.3208-3210								
Cu		KURODA, Naotaka., et al. " Precise control of pn-junction profiles for GaN-based LD structures using GaN substrates with low dislocation densities." Journal of Crystal Growth 189/190 (1998) pp. 551-555								
SV		OHBA, Y., et al" A study on strong memory effects for Mg doping GaN metalorganic chemical vapor deposition." Journal of Crystal growth 145 (1994) pp. 214-218							n	
Ku		BLAAUW, C., et al. "Secondary ion mass spectrometry and electrical characterization of Zn diffusion in n-type inP." J. Appl. Phys. 66(2), July 15, 1989, American Institute of Physics, pp. 805610								
EXAMINER , DATE CONSIDERED										
	Ho	\mathcal{W}	res		5/ 25	S/ 25/05				

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